JP \$40.00 111753

PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

| SUBMISSION TYPE: | NEW ASSIGNMENT |
|-----------------------|----------------|
| NATURE OF CONVEYANCE: | ASSIGNMENT |

CONVEYING PARTY DATA

| Name | Execution Date |
|------------------|----------------|
| Stefan Ottow | 07/22/2005 |
| Kim Woosik | 07/25/2005 |
| Rainer Leuschner | 07/23/2005 |

RECEIVING PARTY DATA

| Name: | Infineon Technologies AG |
|-----------------|--------------------------|
| Street Address: | StMartin-Str. 53 |
| City: | Munich |
| State/Country: | GERMANY |
| Postal Code: | 81669 |

| Name: | Altis Semiconductor |
|-----------------|----------------------------|
| Street Address: | SNC 224 Bld., John Kennedy |
| City: | Corbeil Essonnes Cedex |
| State/Country: | FRANCE |
| Postal Code: | 31 P, 91105 |

PROPERTY NUMBERS Total: 1

| Property Type | Number |
|---------------------|----------|
| Application Number: | 11175386 |

CORRESPONDENCE DATA

Fax Number: (301)762-4056

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

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PATENT REEL: 016359 FRAME: 0115

500043507

| Address Line 4: | Rockville, MAR | YLAND 20850 |
|--|----------------|-------------------|
| NAME OF SUBMITTER: | | Patrick J. Finnan |
| Total Attachments: 3 source=Executed Assign#pa source=Executed Assign#pa source=Executed Assign#pa | ge2.tif | |

PATENT REEL: 016359 FRAME: 0116

INFINEON REF NO. 13602 O.C. REF NO. 3001.0007C

ASSIGNMENT

For good and valuable consideration, WE, Stefan Ottow, a citizen of Germany, residing at 14, Rue Perronet, 92150 Suresnes, France; Kim Woosik, a citizen of Korea, residing at 24, Rue du Mont aux Lievres, 77350 Boissettes, France; and Rainer Leuschner, a citizen of Germany, residing at 8, Route de Champagne, 77210 Samoreau, France, hereinafter individually or collectively referred to as "Assignor";

Hereby sell, assign and transfer to Infineon Technologies AG, a corporation organized and existing under the laws of Germany, having its principal place of business at St.-Martin-Str. 53, 81669 Munich, Germany, and Altis Semiconductor, a corporation organized and existing under the laws of France, having its principal place of business at SNC 224 Bld., John Kennedy, ZIP 31 P, 91105 Corbeil Essonnes Cedex, France, hereinafter "Assignees", its successors, assigns and legal representatives, the entire right, title and interest in and for the United States and all foreign countries, in and to any and all improvements which are disclosed in the application for United States Letters Patent, which has been executed by the undersigned and

METHOD OF TREATING A SUBSTRATE IN MANUFACTURING A MAGENTORESISTIVE MEMORY CELL

and in and to said application and all divisional, continuing, substitute, renewal, reissue, and all other applications for Letters Patent which have been or shall be filed in the United States and all foreign countries on any of said improvements; and in and to all original and reissued patents which have been or shall be filed in the United States and all foreign countries on said improvements;

Agree that said Assignees may apply for and receive Letters Patent for said improvements in its own name; and that, when requested, without charge to but at the expense of said Assignees, their successors, assigns and legal representatives, to carry out in good faith the intent and purpose of this assignment, the undersigned will execute all divisional, continuing, substitute, renewal, reissue, and all other patent applications on any and all said improvements; execute all rightful oaths, assignments, powers of attorney and other papers; communicate to said Assignees, their successors, assigns, and legal representatives, all facts known to the undersigned relating to said improvements and the history thereof; and generally do everything possible which said Assignees, their successors, assigns or legal representatives shall consider desirable for aiding in securing and maintaining proper patent protection for said improvements and for vesting title to said improvements and all applications for patents and all patents on said improvements, in said Assignee, its successors, assigns and legal representatives; and

Covenant with said Assignees, their successors, assigns and legal representatives that no assignment, grant, mortgage, license or other agreement affecting the rights and property herein conveyed has been made to others by the undersigned, and that full right to convey the same as herein expressed is possessed by the undersigned.

| SIGNATURE: | Stra_ | Ollow | , | DATE: | 22-11-7005 |
|------------|--------------|-------|---|-------|------------|
| | Stefan Ottow | | | | 10 |

INFINEON REF NO. 13602 O.C. REF NO. 3001.0007C

| SIGNATURE: | Wob Sik Kim Woosik | k.m | 3 | DATE: | 25. | Jal. | 2005 |
|------------|-----------------------|-----|---|---------|-----|------|------|
| SIGNATURE: | Rainer Leuschner | | | _ DATE: | | • | |

INFINEON REF NO. 13602 O.C. REF NO. 3001.0007C

| SIGNATURE: | Kim Woosik | DATE: | |
|------------|------------|-------|---------|
| SIGNATURE: | | DATE: | 27,7.05 |

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PATENT

REEL: 016359 FRAME: 0119